



**ELECTRONIC COPY**

LG772602177  
Report verification at igi.org



February 8, 2026

IGI Report Number **LG772602177**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **ROUND BRILLIANT**

Measurements **6.47 - 6.50 X 3.81 MM**

**GRADING RESULTS**

Carat Weight **1.00 CARAT**

Color Grade **D**

Clarity Grade **VS 1**

Cut Grade **EXCELLENT**

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**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

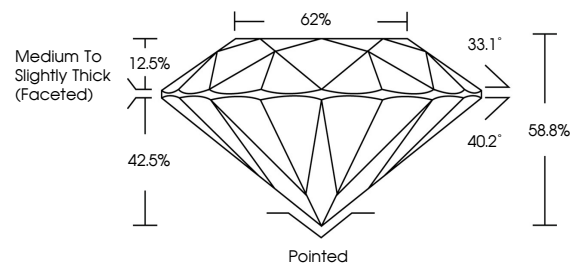
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG772602177**

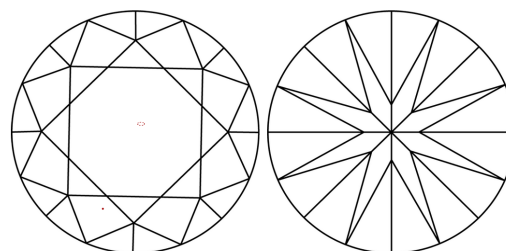
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

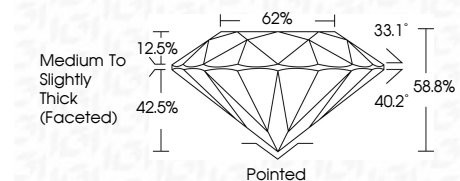
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

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**IGI**



February 8, 2026  
IGI Report No LG772602177  
**ROUND BRILLIANT**

1.00 CARAT  
Color Grade **D**  
Clarity Grade **VS 1**  
Depth **58.8%**  
Table **62%**  
Girdle **Medium To Slightly Thick (Faceted)**

Culet **Pointed**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
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